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Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>				Complete if Known	
				Application Number	Not Yet Assigned
				Filing Date	February 25, 2002
				First Named Inventor	Shunpei YAMAZAKI et al
				Group Art Unit	Not Yet Assigned
				Examiner Name	Not Yet Assigned
				Attorney Docket Number	740756-2443

[illegible]

FOREIGN PATENT DOCUMENTS								
Examiner Initials*	Cited No.	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ^e
		Office ³	Number ⁴	Kind Code ⁵ (if known)				
TW		JP	07-183540 A		T. Fukunaga et al	07/21/1995		W/Abstract
		JP	11-074536 A		Y. Aya et al	03/16/1999		W/Abstract
TU		EP	0 651 431 A2		H. Ohtani et al	05/03/1995		English
Examiner Signature					Date Considered	7/28/05		

¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

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**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(use as many sheets as necessary)

Complete if Known

Application Number	10/081,767
Filing Date	February 25, 2002
First Named Inventor	Shunpei YAMAZAKI et al.
Art Unit	2813
Examiner Name	Thanh Nguyen
Attorney Docket Number	740756-2443

Sheet 1 of 1

U.S. PATENT DOCUMENTS

Examiner Initials [*]	Cite No. ¹	U.S. Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code ² (if known)			
TW		US-5,529,937	06/25/1996	Zhang et al.	
		US-5,569,610	10/29/1996	Zhang et al.	
		US-5,639,698	06/17/1997	Yamazaki et al.	
		US-5,663,077	09/02/1997	Adachi et al.	
		US-5,773,327	06/30/1998	Yamazaki et al.	
		US-5,824,573	10/20/1998	Zhang et al.	
		US-5,879,977	03/09/1999	Zhang et al.	
		US-5,923,997	07/13/1999	Mitanaga et al.	
		US-5,953,597	09/14/1999	Kusumoto et al.	
TW		US-6,319,761 B1	11/20/2001	Zhang et al.	
		US-			

FOREIGN PATENT DOCUMENTS

Examiner Initials [*]	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁴
		Country Code ³ Number ⁴ Kind Code ⁵ (if known)				

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS

Examiner Initials [*]	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²

Examiner Signature		Date Considered	7/28/03
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(Rev. 8-83)U.S. Department of Commerce
Patent and Trademark Office

Atty Docket 0756-2443

Serial No. 10/081,767

INFORMATION DISCLOSURE STATEMENT

Applicants: Shunpei YAMAZAKI et al.

Filing Date: February 25, 2002

Group Art Unit: 2812

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate)
TW	2001/0003659	06/14/2001	Aya et al.			
I	5,854,096	12/29/1998	Ohtani et al.			
I	6,184,068	02/06/2001	Ohtani et al.			
TW	6,326,248	12/04/2001	Ohtani et al.			

OTHER DOCUMENT (Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner Initial	
TW	Kimura et al., "Device Simulation of Interface Roughness in Laser-Crystallized p-Si TFT's", pp. 263-266, 1999, AM-LCD
I	Abe et al., "High-Performance Poly-Crystalline Silicon TFTs Fabricated Using the SPC and ELA Methods", pp. 85-88, July 9-10 1998, AM-LCD
I	Specifications and Drawings for Application Serial No. 10/078,240, "Method of Manufacturing a Semiconductor Device" Filing Date: February 20, 2002, Inventors: Shunpei YAMAZAKI et al.
TW	Specifications and Drawings for Application Serial No. 10/056,054, "Method for Manufacturing a Semiconductor Device"

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07/05/2002